

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re Application of:**

) **Attorney Docket No.**  
 ) FIS920030377US1  
 ) **Confirmation No. 6138**

Huang et al.

)  
)

**Serial No.:** 10/716,785

) **Examiner:** Sin J. Lee

**Filed:** November 19, 2003

) **Group Art Unit:** 1752

**For:** SILICON-CONTAINING RESIST  
 SYSTEMS WITH CYCLIC KETAL)  
 PROTECTING GROUPS )

) **Date:** September 18 2006

The Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

In response to the Final Office Action dated July 18, 2006, please amend  
the above-identified Application as follows: